

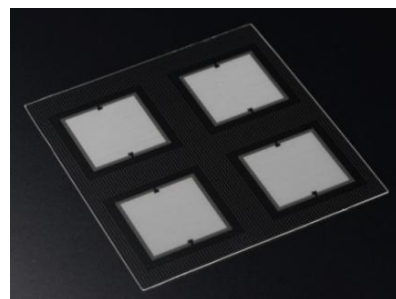
TGV Technology



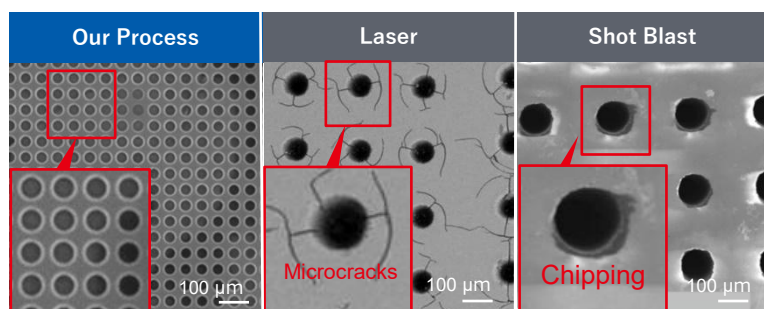
Realization of high-density and high-frequency device support

Features

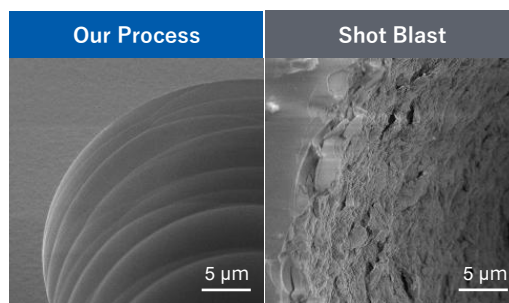
- Dense microholes without microcracks
- Enables wiring to substrates with through-holes
- Providing integrated support for all processes starting from material procurement



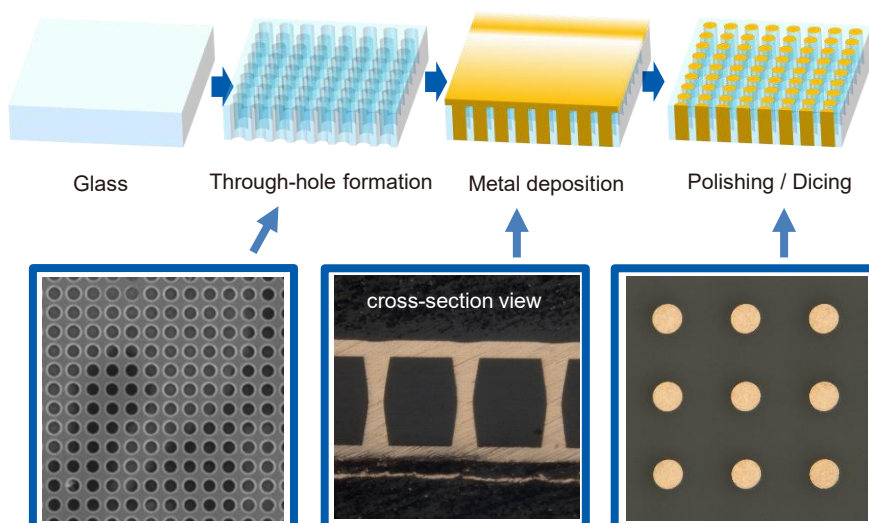
High-density microhole processing without cracks or chips.



The inside walls of our microholes have a roughness of $Ra \leq 0.08 \mu m$.

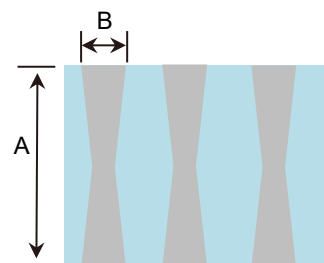


Process Flow



Design

Size	4 inch <
Thickness	100-1000 μm
Aspect ratio	up to 10



Material

Alkali-free glass
Borosilicate glass
Quartz